

## **ABSTRACT OF THE DISCLOSURE**

A defect identifying apparatus marks a defect location, obviating manual marking in the LCD manufacturing process. The defect identifying apparatus includes a microscope and a defect marker. The defect marker is fastened to  
5 a base of the microscope. The defect marker includes an ink jet and a support frame. The support frame is employed to fix the ink jet to the base of the microscope. The ink jet should be positioned between an objective lens and its focal plane so as to avoid scratching the LCD substrate.